

Notice of References Cited

Application/Control No.

10/564,771

Applicant(s)/Patent Under
Reexamination
CHO ET AL.

Examiner

Ajith Jacob

Art Unit

2169

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U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-2003/0108205 A1	06-2003	Joyner et al.	380/277
*	B	US-6,580,756 B1	06-2003	Matsui et al.	375/240.08
	C	US-			
	D	US-			
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	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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